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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : WEI, et al.

U.S. Serial No.: 10/650,365

Examiner: Galvez, James Jason

Filed : August 28, 2003

Art Unit: 1647

For : RECOMBINANT SUPER-COMPOUND INTERFERON

Law Offices of Albert Wai-Kit Chan, LLC
 World Plaza, Suite 604
 141-07 20th Avenue
 Whitestone, NY 11357

June 14, 2005

Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Sir/Madam:

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Upon reviewing the file, Applicants noticed that some of the authors of the references cited in the November 13, 2003 Communication to Submit Information Disclosure Statement and Priority Document that was filed with the United States Patent and Trademark Office were incorrect. Accordingly, Applicants would like to correct the names of inventors for the following Chinese Patent Nos. that were previously filed on November 13, 2003 to read as follows:

Chinese Patent No. CN 1099799A (reference no. 10) for Hauptmann, et al.

Chinese Patent No. CN 1120846A (reference no. 11) for Reichert, et al.

Chinese Patent No. CN 1186120A (reference no. 12) for Huang, Yun Qiang

Chinese Patent No. CN 1217660A (reference no. 13) for Blatt, Larry and Klein, Michael

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Chinese Patent No. CN 1256148A (reference no. 14) for Zhang, Lei

Chinese Patent No. CN 1291198A (reference no. 15) for Hogarth, et al.

Chinese Patent No. CN 1384116A (reference no. 16) for Jiang, Chun Lei and Wang, Yun Xia

Chinese Patent No. CN 1098103C (reference no. 17) for Blatt, Lawrence M. and Taylor, Milton W.

Chinese Patent No. CN 1062565C (reference no. 18) for Zhao, et al.

Accordingly, Applicants would like to replace Forms PTO/SB/08A, previously submitted as pages 1 and 2 of Exhibit A filed on November 13, 2003, with replacement sheets filed herewith as **Exhibit A**, which embodies the corrections made.

Furthermore, in accordance with their duty of disclosure under 37 C.F.R. §1.56, Applicants would like to direct the Examiner's attention to the following references which are listed below as **Exhibits 1-7** and on Form PTO/SB/08A (**Exhibit B**). The following references are attached:

1. DE 4329756 for Hauptmann, et al., March 9 1995, Method of Preparation and Purification of IFN- α [**Exhibit 1**]

This is a priority application of Chinese Patent No. CN 1099799A (reference number 10) that was previously filed on November 13, 2003.

2. WO 94/19373 for Reichert, et al., September 1, 1994, Metal-Interferon- α Crystals [**Exhibit 2**]

3. U.S. Patent No. 5,441,734, issued August 15, 1995, for Reichert, et al., Metal-Interferon- α Crystals [**Exhibit 3**]

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These are priority applications of Chinese Patent No. CN 1120846A (reference number 11) that was previously filed on November 13, 2003.

4. WO 97/27866 for Blatt, Larry and Klein, Michael, published August 7, 1997, Method for Retreatment of Patients Afflicted with Hepatitis C Using Consensus Interferon **[Exhibit 4]**

5. U.S. Patent No. 5,980,884, issued November 9, 1999 for Blatt, Larry and Klein, Michael, Methods for Retreatment of Patients Afflicted with Hepatitis C Using Consensus Interferon **[Exhibit 5]**

These are priority applications of Chinese Patent No. 1217660A (reference number 13) that was previously filed on November 13, 2003.

6. WO 99/40117 for Hogarth, et al., published August 12, 1999, Three-Dimensional Structures and Models of Fc Receptors and Uses Thereof **[Exhibit 6]**

This is a priority application of Chinese Patent No. CN 1291198A (reference number 15) that was previously filed on November 13, 2003.

7. U.S. Patent No. 5,372,808, issued December 13, 1994 for Blatt, Lawrence M. and Taylor, Milton W., Methods and Compositions for the Treatment of Diseases with Consensus Interferon while Reducing Side Effect **[Exhibit 7]**

This is a priority application of Chinese Patent No. CN 1098103C (reference number 17) that was previously filed on November 13, 2003.

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If a telephone interview would be of assistance in advancing prosecution of the subject application, Applicants' undersigned attorney invites the Examiner to telephone him at the number provided below.

No fee is deemed necessary in connection with the filing of this Supplemental Information Disclosure Statement. However, if any additional fee is required, authorization is given to charge the amount of any such fee to Deposit Account No. 50-1891.

Respectfully submitted,

Albert Wai Kit Chan

I hereby certify that this paper is being deposited this date with the U.S. Postal Service with sufficient postage for first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.		Albert Wai-Kit Chan Registration No. 36,479 Attorney for Applicants Law Offices of Albert Wai-Kit Chan, LLC World Plaza, Suite 604 141-07 20 th Avenue Whitestone, New York 11357 Tel: (718) 799-1000 Fax: (718) 357-8615 E-mail: chank@kitchanlaw.com
<u>Albert Wai Kit Chan</u>	<u>6/14/05</u>	Date
Albert Wai-Kit Chan Reg. No. 36,479		



Substitute for form 1449/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet 1 of 4

Complete if Known

Application Number	10/650,365
Filing Date	August 28, 2003
First Named Inventor	WEI, et al.
Art Unit	
Examiner Name	
Attorney Docket Number	792-A-PCT-US

FOREIGN PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)			
10	CN-1099799A		03-08-1995	Hauptmann, et al.	
11	CN-1120846A		04-17-1996	Reichert, et al.	
12	CN-1186120A		07-01-1998	Huang, Yun Qiang	
13	CN-1217660A		05-26-1999	Blatt, Larry and Klein, Michael	
14	CN-1256148A		06-14-2000	Zhang, Lei	
15	CN-1291198A		04-11-2001	Hogarth, et al.	

Examiner Signature		Date Considered	
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***EXAMINER:** Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: **Commissioner for Patents, Washington, DC 20231.**

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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of 4

Application Number 10/650,265

Application Number	10/650,365
Filing Date	August 28, 2003
First Named Inventor	WEI, et al.
Art Unit	
Examiner Name	

Attorney Docket Number 792-A-PCT-US

U. S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear	T ⁶
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)				
	16	CN-1384116A	12-11-2002	Jiang, Chun Lei and Wang, Yun Xia		
	17	CN-1098103C	01-08-2003	Blatt, Lawrence M. and Taylor, Milton W.		
	18	CN-1062565C	02-28-2001	Zhao, et al.		
	19	EP-0083734B1	12-03-1982	Kung, et al.		
	20	EP-0736303B1	03-30-1996	Gross, et al.		
	21	EP-0777495B1	10-10-1995	Pui-Ho Yuen, Douglas Kline		

Examiner Signature		Date Considered	
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***EXAMINER:** Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.¹ Applicant's unique citation designation number (optional).² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04.³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3).⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document.⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible.⁶ Applicant is to place a check mark here if English language Translation is attached.

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